



ELECTRONIC COPY

LG659461098  
Report verification at igi.org



October 15, 2024  
IGI Report Number **LG659461098**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED RECTANGULAR MIXED CUT**  
Measurements **11.65 X 7.75 X 5.31 MM**  
**GRADING RESULTS**  
Carat Weight **5.02 CARATS**  
Color Grade **E**  
Clarity Grade **INTERNALLY FLAWLESS**

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GRADING RESULTS

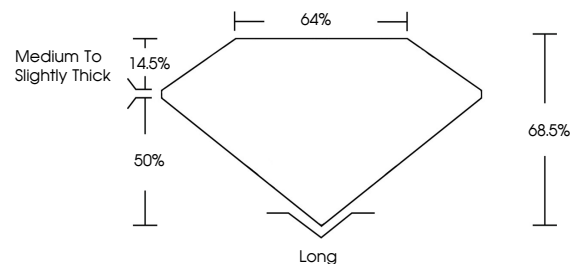
Carat Weight **5.02 CARATS**  
Color Grade **E**  
Clarity Grade **INTERNALLY FLAWLESS**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG659461098**

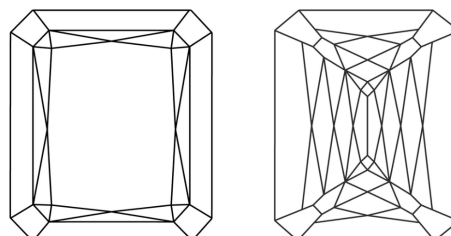
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

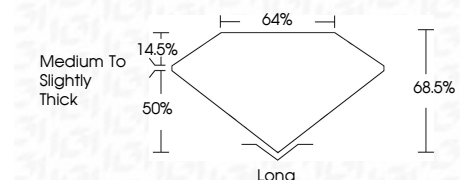
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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IGI



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**CUT CORNERED RECT. MIXED CUT**  
**11.65 X 7.75 X 5.31 MM**  
**5.02 CARATS**  
**E**  
**LF**  
**68.5%**  
**50%**  
**Medium to Slightly Thick**  
**Long**  
**EXCELLENT**  
**EXCELLENT**  
**NONE**  
**IGI LG659461098**  
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Type IIa